

Appl. No. 09/699,897

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/699,897
Filing Date October 27, 2000
Inventor..... Mathew S. Cooper
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1753
Examiner R. McDonald
Attorney's Docket No. H0001190 (4016)
Title: Physical Vapor Deposition Components and Methods of Formation

RESPONSE TO JULY 30, 2003 OFFICE ACTION

To: Art Unit 1753
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

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AMENDMENTS